

Editorial office: The Society of Powder Technology, Japan
No.5 Kyoto Bldg., 181 Kitamachi, Karasuma-dori, Rokujo-agaru, Shimogyo-ku, Kyoto 600-8176, Japan
Tel.+81-(0)75-351-2318, Fax.+81-(0)75-352-8530, Email.ap@aptj.jp
<http://www.journals.elsevier.com/advanced-powder-technology>

Advanced Powder Technology ICCCI2015 Special Issue Guest edited by M. Naito, K.G. Ewsuk, J. Tatami, M. Iijima

<Regarding your submission>

It is happy to announce that Advanced Powder Technology is planning to publish the peer-reviewed and selected special issue of the 5th International Conference on the Characterization and Control of Interfaces for High Quality Advanced Materials (ICCCI 2015) as Vol.27 No.5 (September, 2016). Before your submission, please have a read our Guide for Authors as well as the following notes. We look forward to receiving more active submissions through Elsevier Editorial System (EES).

Due date to submit original manuscript: August 31, 2015

Preparation: Guide for authors <http://www.elsevier.com/locate/apt>

►Our editorial policy requires Corresponding Author to use the e-mail address they were given by their professional affiliation (university/institution/company). ►Please use 'Highlights' in the file name and include 3 to 5 bullet points (maximum 85 characters, including spaces, per bullet point). ►Please see the sample list of references and follow it. ►Regarding the color reproduction in print, please see Color artwork.

Submission through: Elsevier Editorial System (EES) <http://ees.elsevier.com/apt/>

►We recommend that in order to successfully receive communications from the EES site for the journal you add the domain 'eesmail.elsevier.com' to your Safe Senders or Safe Recipients list. ►Please select either "SI-ICCCI2015-original" or "SI-ICCCI2015-review" as Article type. ►Please select "Makio Naito, Guest Editor for SI-ICCCI2015" as Requested Editor. ►Registering three or more Suggested Reviewers' information, including their email address given by their professional affiliation (university/institution/company) is required. Any suggested reviewers with the free email address such as Gmail or Yahoo are not received. ►The Information of the Open Access Policy of our journal is available through (<http://www.elsevier.com/journals/advanced-powder-technology/0921-8831/open-access-options>) ►Please be advised that manuscripts submitted after the due date or not submitted within the 8-week revision term may be published in any of the normal issues.

*Our editorial policy requires all submissions to be checked through CrossCheck.
(<http://www.crossref.org/crosscheck/index.html>)

Any inquiries:

About this journal, Advanced Powder Technology

Contact: Editorial office liaison of Advanced Powder Technology, Email: apt@sptj.jp

About Elsevier Editorial System (EES)

Contact: Elsevier B.V. Researchers Support: E-mail: support@elsevier.com
or

See *Elsevier Editorial System (EES) User Guide for Authors*

http://help.elsevier.com/app/answers/detail/a_id/116/p/7923/c/7928